INTERNATIONAL GEMOLOGICAL INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

April 23, 2026

IGI Report Number	LG794649498
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	RECTANGULAR CUSHION MIXED CUT
Measurements	10.80 X 7.21 X 4.62 MM

GRADING RESULTS

Carat Weight	3.68 CARATS
Color Grade	E
Clarity Grade	VVS 2

ADDITIONAL GRADING INFORMATION

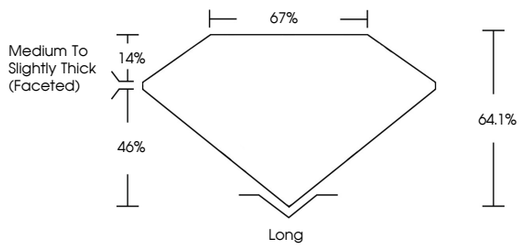
Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	IGI LG794649498

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG794649498

Report verification at igi.org

PROPORTIONS



Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

© IGI 2020, International Gemological Institute

FD - 10 20

THIS DOCUMENT WAS PRODUCED WITH THE FOLLOWING SECURITY MEASURES: SPECIAL DOCUMENT PAPER, INK SCREENS, WATERMARK BACKGROUND DESIGNS, HOLOGRAM AND OTHER SECURITY FEATURES NOT LISTED AND DO EXCEED DOCUMENT SECURITY INDUSTRY GUIDELINES.

www.igi.org

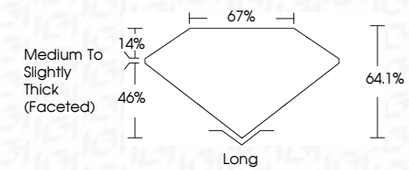
LABORATORY GROWN DIAMOND REPORT

April 23, 2026

IGI Report Number	LG794649498
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	RECTANGULAR CUSHION MIXED CUT
Measurements	10.80 X 7.21 X 4.62 MM

GRADING RESULTS

Carat Weight	3.68 CARATS
Color Grade	E
Clarity Grade	VVS 2



ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	IGI LG794649498

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

IGI

April 23, 2026
IGI Report No LG794649498
RECTANGULAR CUSHION MIXED CUT
10.80 X 7.21 X 4.62 MM

Carat Weight	3.68 CARATS
Color Grade	E
Clarity Grade	VVS 2
Depth	64.1%
Table	67%
Girdle	Medium To Slightly Thick (Faceted)
Culet	Long
Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	IGI LG794649498

Comments:
This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa